

AF JFW



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Group Art Unit: 2811

Examiner: Junghwa M. IM

In Re PATENT APPLICATION Of:

Applicant: Kazutaka SHIBATA

Serial No.: 10/608,016

Filed: June 30, 2003

For: SEMICONDUCTOR DEVICE AND  
MANUFACTURING METHOD THEREOF

Docket No.: AI 288

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)  
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)  
) **AMENDMENT**  
) **AFTER**  
) **FINAL ACTION**  
)  
)

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October 22, 2007

**Mail Stop AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

This amendment is filed in response to the Examiner's Final Action mailed on July 25, 2007. Please amend the above-identified application as follows: